



Synthesis and characterization of brookite/anatase complex thin film

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ABSTRACT

TiO₂ films were prepared on a silicon or soda-glass substrate using a sol suspension. The TiO₂ film on the silicon substrate was composed of pure anatase phase and showed almost no contaminations. In contrast, the TiO₂ film on the soda-glass substrate was composed of anatase and brookite phases. The diffusion of Na into the TiO₂ film on the soda-glass substrate was observed by XPS, and Na was concentrated on the surface of the film. The yield of the brookite phase increased with decreasing distance from the surface of the film on the soda-glass substrate. Na promoted the formation of the brookite phase, although the preparative procedure was used for anatase synthesis.

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1. Introduction

Titanium dioxide (TiO₂) has been investigated extensively for many years because of its various applications as a low-cost material in photocatalysis [1–3], in photovoltaics [4,5], in electrochromic [6] or as gas sensor [7,8]. The use of TiO₂ as a catalyst during photochemical oxidation aimed at decomposing organic compounds is well known [9]. TiO₂ exists in three different crystalline phases: rutile (tetragonal), anatase (tetragonal) and brookite (orthorhombic). In nature, rutile is the most common, while brookite is scarce. Among these phases, anatase and rutile can be obtained by several synthetic methods and their various properties have been widely studied. Recent reports on the preparation of pure brookite and the study of its characteristics are limited [10–12]. Some reports indicated that brookite-type TiO₂ shows high photoinduced hydrophilicity and high photocatalytic activity compared with rutile and anatase [13,14]; thus, brookite is a good candidate material for solar-energy conversion devices.

Brookite is the metastable phase of TiO₂; thus, it is difficult to prepare pure brookite under laboratory conditions. Many researchers reported that it is typically obtained as an accessory second phase when rutile or anatase is synthesized [15–17]. It has been shown that the titania phase, which is the most difficult phase to prepare in thin-film form, is brookite [18,19]. Brookite/anatase complex films have been obtained by various techniques, such as

pulsed laser deposition [20] and the electrochemical oxidation of titanium electrodes [21]. Djaoued et al. [22] have prepared brookite-rich films by a sol–gel method using diethanolamine and polyethylene glycol as modulators. Recently, Kuznetsova et al. [23] have prepared a spin-coated film of pure brookite with a preferred orientation.

We prepared TiO₂ films on silicon and soda-glass substrates using a sol suspension. This suspension was coated onto the substrates by dip coating. The TiO₂ film on the silicon substrate was found to be composed of pure anatase phase by grazing incident asymmetric X-ray diffraction (GIAXRD) analysis. However, the TiO₂ film on the soda-glass substrate was composed of anatase and brookite phases. In this work, we characterized these TiO₂ films by GIAXRD analysis and X-ray photoelectron spectroscopy (XPS). These measurements revealed the difference between the film on the silicon substrate and that on the soda-glass substrate. We also discussed the mechanism of brookite phase generation on the soda-glass substrate.

2. Experimental

2.1. Preparation of TiO₂ films

TiO₂ thin films were prepared by dip coating using a sol suspension on soda-glass and silicon substrates. Titanium tetraisopropoxide (TTIP) (90.6 ml) was used as the starting material. The required amount of ethanol (93.8 ml) was divided into two parts: the first part was added to the stirred TTIP. The second part was mixed with 5.2 ml of hydrochloric acid solution (38 wt.%) and then added dropwise (1.5 cm/min) into the solution with stirring

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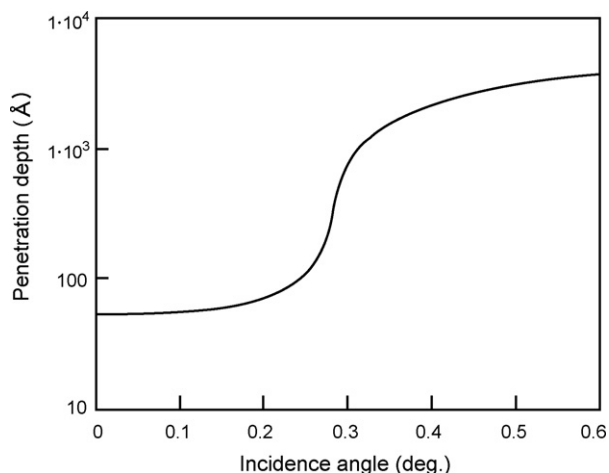


Fig. 1. X-ray penetration depth for TiO₂ as function of incidence angle.

to promote hydrolysis. This homogenous solution was continuously stirred for 24 h at room temperature.

The soda-glass and silicon substrates were first cleaned carefully in an ultrasonic bath. Using this prepared solution, the TiO₂ thin films coated onto the substrates (soda glass or quartz) by dip coating. The films were then dried in a desiccator for 10 min and subsequently calcined at 500 °C in air for 2 h. After cooling to room temperature, the dip coating and calcination process were repeated. The TiO₂ film thickness was about 150 nm.

2.2. Characterization

The crystallographic properties of the TiO₂ films were determined by GIXRD analysis using a monochromatic Cu K α radiation. Incidence angle was used to determine the change in the crystal phase along the film depth. The variation in the penetration depth of TiO₂ as a function of incidence angle is shown in Fig. 1. Diffraction patterns were obtained in a 2θ angular range from 24.0° to 32.0°.

The surface chemical compositions of the TiO₂ films were determined by XPS. Spectra were collected using a monochromatic Mg K α source with an energy of 1253.6 eV operated at 10 kV. For the TiO₂ film on the soda-glass substrate, elemental depth profiling was carried out using Ar⁺ sputtering beams under the applied conditions (3 keV, 8 mA).

3. Results and discussion

The GIXRD patterns of the TiO₂ films are shown in Fig. 2. The GIXRD patterns of the TiO₂ film on the silicon substrate (Fig. 2(a)) were obtained at grazing incidence angles from 0.2° to 0.5°. The diffraction line at about 25.5° was the 101 line of the anatase phase, and the sample was confirmed to be single-phase anatase from the upper layer to the lower layer. The diffraction patterns of the TiO₂ film on the soda-glass substrate (Fig. 2(b)) were obtained at grazing angles of incidence from 0.2° to 0.6°. The diffraction line at about 30.9°, which was assigned to the 121 line of the brookite phase, was observed in addition to those from the anatase phase. The intensity of this line relative to the strongest 120 line of the brookite phase at 25.4° was about 90%. However, this relative intensity in Fig. 2(b) was clearly low. This result shows that the anatase and brookite phases coexist in the TiO₂ film on the soda-glass substrate. Therefore, the strongest diffraction line at about 25.4° overlaps the 120 line of the brookite phase (2θ (Cu K α_1) = 25.339° from JCPDS 29-1360) and the 101 line of the

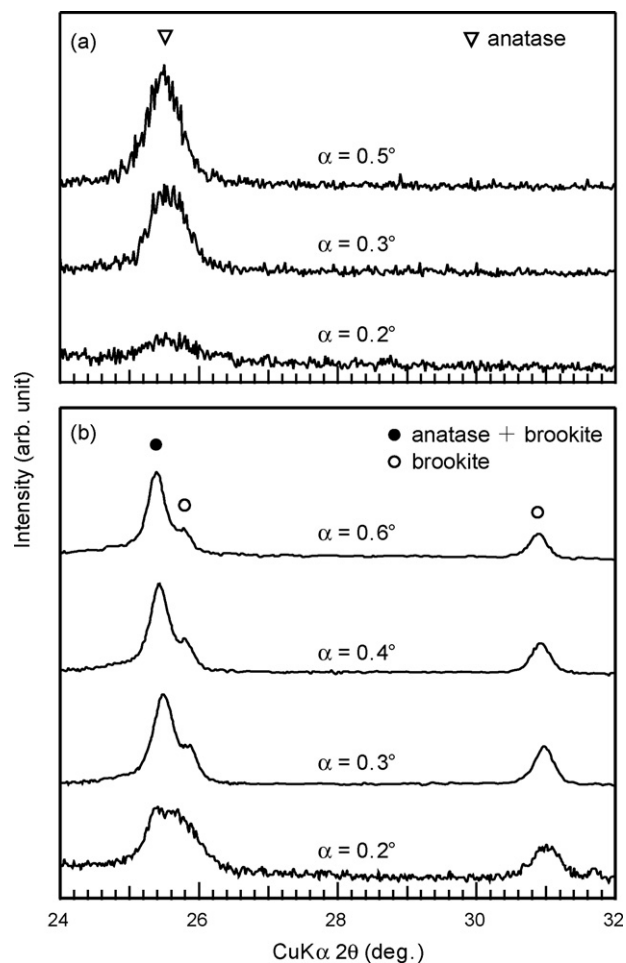


Fig. 2. GIXRD patterns of TiO₂ films on (a) silicon and (b) soda-glass substrates.

anatase phase (2θ (Cu K α_1) = 25.281° from JCPDS 21-1272), and the diffraction shoulder at about 25.8° is the 111 line of the brookite phase.

Fig. 3 shows the intensity of the 121 diffraction line of the brookite phase relative to that of multiple lines at around 25.0–

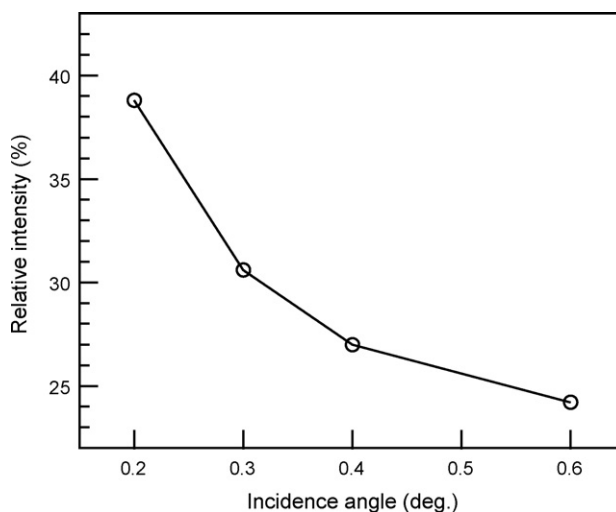


Fig. 3. Intensity of diffraction line 121 of brookite phase relative to multiple lines at around 25.0–26.0° in diffraction patterns of TiO₂ film on soda-glass substrate as function of incidence angle.

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